

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

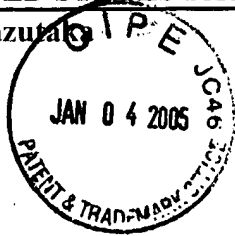
Applicant(s): Manabe, Kazutaka

Serial No.: 10/618,508

Filed: July 11, 2003

Title: Semiconductor Device and Its
Manufacturing Method

Attorney Docket No.: N09692401WD1



Group Art Unit: 2824

Examiner: Menz, Douglas M.

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

The following is submitted in response to the Office Action dated **December 2, 2004**, and is currently due **January 3, 2005**.

37 C.F.R. §1.8

I hereby certify that this correspondence is being

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Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit: December 30, 2004

Typed/Printed Name: Darryl Walker

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